

Notice of References Cited	Application/Control No. 10/642,299	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Krishnan S. Menon	Art Unit 1723	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0053422	03-2004	Chan et al.	436/180
*	B	US-6,814,859	11-2004	Koehler et al.	210/198.2
	C	US-			
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	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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